

Modeling of Irradiation Effects in sub-N7 CMOS Logic Devices Using Layout-Based Design

Oskar Baumgartner, Markus Karner, Hui-Wen Karner, Christian Kernstock, Franz Schanovsky, Georg Strof Pete Truscott (Kallisto Consultancy)

Model Suite for full Logic Cells

TCAD based analysis of a full NAND Gate: Power, Performance, Area, Variability, and Reliability





GTS Framework – Minimos NT



Semiconductor device simulator

- General-purpose semiconductor
 device simulator
- Planar and non-planar CMOS
- Power electronics based on wide band gap materials

Non-volatile memory

- Mixed-mode simulation
- Discrete traps and dopants

Variability time zero: RDD, MGR, LER Statistical reliability: BTI, HCD





Effects in Emergent Devices



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TCAD

Radiation Effects Prediction Process





Deep Sub-Micron CMOS Radiation Effects (DESMICREX)

Sponsored by ESA to

- develop simulation environment for modelling DSM CMOS radiation effects
- Identify example DSM CMOS technology and implement in test vehicles
- Simulation environment based on Geant4/GRAS operating within GTS Framework with MINIMOS-NT

Significant strides made:

- Version of GRAS which can read-in standard format microelectronics structures and simulate ion tracks
- Cost-effective multi-platform/multi-CPU TCAD Framework to treat mixed-mode MINIMOS-NT +BSIM4

No follow up development on Geant4/GRAS integration



Tool Flow for Irradiation Simulation



Simulation of a single event transient (SET) on an inverter chain (From **device layout** to **circuit simulation**, all set up in less than **1 hour**)



Simulation of a single event up-set (SEU) on a 90nm 6T-SRAM



Modeling of Radiation Effects in Flash Memories

Transnational project started 2016 and funded by

- Austrian Research Promotion Agency FFG
- Chinese Academy of Science

Partners

- Device production and testing by Institute of Microelectronics CAS / Synchrotron Beijing
- Device physics modeling by TU Wien and GTS
- Geant4 integration by Pete Truscott and GTS
- Revamped effort of combining Geant 4 and Device TCAD
 - Great advances in GTS device structure generation
 - Require solution compatible with GRAS license and GTS IP



Requirement for Radiation Effects Analysis and Priority

- 1. Single event latch-up
 - Effects of angle, impact position, temperature
- 2. Single event transients / DSETs + Multiple Transients
 - Effects of angle, position, clock-freq, cross-talk, temperature
- 3. Single event upsets / multiple-cell upsets
 - Effects of angle, position, temperature
- 4. Single event hard error (stuck bits)
- 5. Total ionising dose
 - Intra- and inter-device leakage across STI
- 6. Dose enhancement effects
 - Use of Cu and other high-Z materials





SET - Charge Collection



Spatial generation rate profile



SET - Charge Collection



Contact current over time



SET - Charge Collection



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SET – Time Discretization



Contact current over time



SET – Time Discretization



Charge collection over inverse step width $1/\Delta t$



Inverter - SET



Mixed-mode circuit



Inverter - SET





Inverter - SET







Compact circuit





Device structure with net doping concentration





Device structure with interconnects





Device structure with interconnects and grid





Mixed-mode Circuit





Full 6T FinFET SRAM with rate generation profile





Potential profile before impact





Potential profile after impact



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Scripting engine / DoE





Time evolution of Q/Qn outputs during impact at various sites





Device top view with DOE ion impact points and min VQn



Summary & Outlook

Layout-Based Structure Generation

- Automated setup for different technologies (FinFET, NW)
- Meshing appropriate for technology and irradiation simulation

Physical Device Simulation for N7 and sub-N7

- Subband-BTE (phase-space) solver for emergent devices
- Capture effects of quantization, ballisticity, scattering

Irradiation Simulation

- Proof of concept implemented with GRAS
- Needs to be ported to Geant4 (ongoing)
- Analytical beam profiles for faster turn around
- Automated DoE allows for investigation of critical points
- Work in progress for flash devices (transnational project)



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